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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Complete if Known

Application Number	10/644,827
Confirmation Number	6185
Filing Date	August 21, 2003
First Named Inventor	Takeshi FUKUDA
Art Unit	2876 2883
Examiner Name	Ryan A. LEPISTO
Attorney Docket Number	Q76740

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ³ (if known)		
		US			
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ²	Number ⁴	Kind Code ³ (if known)			
RAL		JP	2001-350049	A	12/21/2001	NIPPON SHEET GLASS CO LTD	Abstract
RAL		JP	9-311237		12/02/1997	KAGAKU GIJUTSU SHINKO JIGYODAN; MIURA SEIKI	Abstract

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
RAL		T. Fukuda et al., "Writing Waveguides in Pure Silica Glass by Femtosecond Laser Pulses", THE JAPAN SOCIETY OF APPLIED PHYSICS, 63 rd Annual Meeting, 27p-YB-5, September 2002	Yes
QAL		S. Ishikawa et al. "Writing Waveguides in Pure Silica Glass by Femtosecond Laser Pulses" THE INSTITUTE OF ELECTRONICS, INFORMATION AND COMMUNICATION ENGINEERS, Society Conference, 2002. 9	Yes
RAL		Matthias Will et al., "Optical properties of waveguides fabricated in fused silica by femtosecond laser pulses", APPLIED OPTICS, vol. 41, no. 21, July 20, 2002, pages 4360-4364.	

Examiner Signature

Ryan Lepisto

Date Considered

10/8/07

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to indicate here if English language Translation is attached.